H. Toshiyoshi/A. TIXIER-MITA LAB.

[MEMS/NEMS]

Centre for Interdisciplinary Research on Micro-Nano Methods





Micro Machine System Engineering

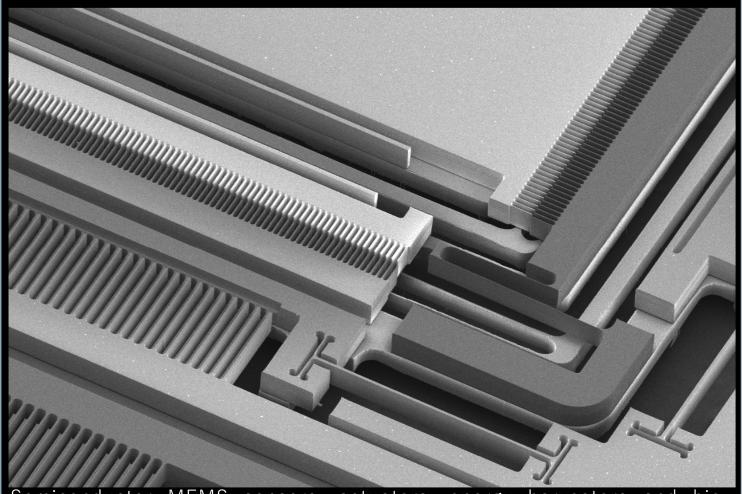
Electrical Engineering course

Department of Electrical Engineering and Information Systems

http://toshi.iis.u-tokyo.ac.jp/toshilab

Comme Ça de MEMS

MEMS Actuators and Sensors



Semiconductor MEMS sensors, actuators, energy harvesters and biosensing are our research interests. Regardless your status of students or corporate researchers, anyone who is interested in multiple technical layers from materials, processes, devices, systems through IoT services is welcomed here, where your technological perspectives are cultivated.

